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Pat. No. 7,427,463 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | Heidi Cao et al. | Docket: P17315 |
| Patent No.: | 7,427,463 | Issued: 09-23-2008 |
| Title: | PHOTORESISTS WITH REDUCED OUTGASSING FOR EXTREME ULTRAVIOLET LITHOGRAPHY | |

## REVOCATION AND POWER OF ATTORNEY
## CERTIFICATE UNDER 37 CFR § 3.73(b)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In accordance with 37 C.F.R. Section 1.36, M.P.E.P. Section 402.05 and 402.07, please revoke any existing Powers of Attorney, if any, and appoint the following attorneys and/or patent agents to prosecute this application and to transact all business in the Patent and Trademark Office in connection therewith:

**Customer Number: 59796**

## CERTIFICATE UNDER 37 CFR § 3.73(b)

Intel Corporation hereby certifies that it is the assignee of the entire right, title and interest in the patent application identified above by virtue of an assignment from the inventor recorded on December 18, 2003 Reel 014804, and Frame 0035. To the best of my knowledge and belief, title is in Intel Corporation, the assignee.

Pursuant to 37 C.F.R. § 3.73(b) I hereby declare that I, Pam J. Matlock, am empowered to sign this certificate on behalf of Intel Corporation, the assignee.

I hereby declare that all statement made herein of my own knowledge are true, and that all statements made on information and belief are believed to be true.

Please direct all correspondence in this case to:

**Rahul Engineer**
**c/o CPA Global**
**Customer Number: 59796**

Date August 9, 2010 By Pam Matlock
Pam J. Matlock
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